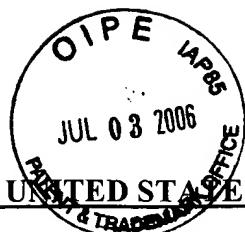


S/N 09/471,460



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Thomas A. Figura et al. Examiner: Calvin Lee
Serial No.: 09/471,460 Group Art Unit: 2818
Filed: December 22, 1999 Docket No: 303.932US4
Title USE OF A PLASMA SOURCE TO FORM A LAYER DURING THE
FORMATION OF A SEMICONDUCTOR DEVICE

PETITION FOR A TWO-MONTH EXTENSION OF TIME

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In accordance with the provision of 37 CFR § 1.136(a), it is respectfully requested that a two-month extension of time be granted in which to respond to the Office Action mailed February 7, 2006, said period of response being extended from May 7, 2006 to July 7, 2006.

Please charge Deposit Account No. 19-0743 in the amount of \$450.00 to cover the required extension fee. Please charge any additional fees or credit overpayment to deposit Account No. 19-0743.

Respectfully Submitted

THOMAS A. FIGURA ET AL.

07/06/2006 HGUTEMA1 00000026 190743 09471460
01 FC:1252 450.00 DA

By their Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
P.O. Box 2938
Minneapolis, MN 55402
(612) 349-9587

Date: 29 June '06 By: 

Timothy B. Clise
Reg. No: 40,957

CERTIFICATE UNDER 37 CFR § 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 29 day of June 2006.

Name: LATE GANON

Signature: Lates G